N.THEがNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yim, et al.

Serial No.: 10/773,060

Confirmation No.: 5473

Filed:

February 4, 2004

For: Ultra Low Dielectric Materials
Based on Hybrid System of Linear
Silicon Precursor and Organic
Porogen by Plasma-Enhanced
Chemical Vapor Deposition

(PECVD)

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1762

Examiner: Marianne L. Padgett

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on 2005, with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

6/9/05

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The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

06/14/2003-DENMANU1-00000049-501074 10806935

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The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Authorization to charge the sum of \$180.00 due under 37 CFR § 1.17(p) pursuant to § 1.97, is given on a separate fee transmittal.

Respectfully submitted,

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PTO/SB/08a (08-03) Approved for use through 07/31/2006. OMB 0651-0031

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Substitute for form 1449A/PTO

Complete if Known Application Number 10/773,060 Filing Date **FEBRUARY 4, 2004** First Named Inventor YIM, ET AL 1762 Examiner Name MARIANNE L. PADGETT

(Use as many sheets as necessary)

Sheet of 1 AMAT/7034.P1/DSM/LOW KJW Attorney Docket Number

U.S. PATENT DOCUMENTS						
Examiner Initials *	Cite No.1	Document Number Publication Date	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number - Kind Code ² (if known)	MM-DD-YYYY			
	A1	US-6,846,515	01/25/2005	VRTIS, ET AL.	-	
	A2	US-2004/0175957	05/20/2004	LUKAS, ET AL.		
	А3	US-2004/0175501	09/09/2004	LUKAS, ET AL.		
	A4	US-2004/0096672	05/20/2004	LUKAS, ET AL.		
	A5	US-2004/0096593	05/20/2004	LUKAS, ET AL.		

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document	, Publication	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T [®]		
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Date MM-DD-YYYY	Applicant of Cited Document				
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.